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1449A/PTO

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(use as many sheets as necessary)

Sheet 1 of 3

Substitute for form 1449A/PTO		<i>Complete if Known</i>	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(use as many sheets as necessary)</i>		Application Number	09/944,499
		Filing Date	August 30, 2001
		First Named Inventor	Akram et al.
		Group Art Unit	2827
		Examiner Name	A. Chambliss
Sheet	1	of	3
		Attorney Docket Number	3936.1US (99-0066.01/US)

U.S. PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS

Examiner
Signature

Date
Considered

41404

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¹ Applicant's unique citation designation number (optional). ² See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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Sheet

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Application Number	09/944,499
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Attorney Docket Number	3936.IJUS/99-0066.01/IJUS

OTHER PRIOR ART – NON PATENT LITERATURE DOCUMENTS

Examiner Initials *	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
AC		U.S. Patent Application Publication No. 2002/0105074 A1 to Akram et al., dated August 8, 2002	
AC		U.S. Patent Application Publication No. 2002/0171177 A1 to Kritchman et al., dated November 21, 2002	
		U.S. Patent Application Publication No. 2003/0022462 A1 to Farnworth et al., dated January 30, 2003	
		U.S. Patent Application Publication No. 2003/0089999 A1 to Akram, dated May 15, 2003	
		U.S. Patent Application Publication No. 2003/0092220 A1 to Akram, dated May 15, 2003	
		U.S. Patent Application Publication No. 2003/0098499 A1 to Akram et al., dated May 29, 2003	
		U.S. Patent Application Publication No. 2003/0139030 A1 to Grigg, dated July 24, 2003	
		U.S. Patent Application Publication No. 2003/0151167 A1 to Kritchman et al., dated August 14, 2003	
		U.S. Patent Application Publication No. 2003/0170921 A1 to Akram, dated September 11, 2003	
		U.S. Patent Application Publication No. 2003/0173665 A1 to Grigg, dated September 18, 2003	
AC		U.S. Patent Application Publication No. 2003/0176016 A1 to Grigg, dated September 18, 2003	

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PTO/SB/08B(10-01)

Approved for use through 10/31/2002. OMB 0651-0031

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AC		U.S. Patent Application Publication No. 2003/0203612 A1 to Akram et al., dated October 30, 2003	
		MILLER et al., "Maskless Mesoscale Materials Deposition", Deposition Technology, September 2001, pages 20-22	
		MILLER, "New Laser-Directed Deposition Technology", Microelectronic Fabrication, August 2001, page 16	
		Webpage, Objet Prototyping the Future, Objet FullCure700 Series, 1 page	
		Webpage, Objet Prototyping the Future, How it Works, 2 pages	
		U.S. Patent Application No. 09/590, 527, filed June 8, 2000, entitled "Structures For Stabilizing Semiconductor Devices Relative to Test Substrates and Methods for Fabricating the Stabilizers", inventor Salman Akram	
		U.S. Patent Application No. 10/201,208, filed July 22, 2002, entitled "Thick Solder Mask for Confining Encapsulant Material Over Selected Locations of a Substrate, Assemblies Including the Solder Mask, and Methods", inventor Grigg et al.	
AC		U.S. Patent Application No. 10/688,354, filed October 17, 2003, entitled "Thick Solder Mask for Confining Encapsulant Material Over Selected Locations of a Substrate and Assemblies Including the Solder Mask", inventor Grigg et al.	

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